

In re application of: NAKAMURA, Shunji, et al.

Serial Number: 10/708,792

Filed: March 25, 2004

For. SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING

**SAME** 

## **INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

March 25, 2004

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and

Trademark Office the references listed on the attached PTO-1449.

## Reference AI is discussed at page 5 of the specification.

A copy of each of the references is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. <u>01-2340</u>.

Respectfully submitted,

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PATENT TRADEMARK OFFICE

Enclosures: PTO-1449; References (5)

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U.S. PATENT DOCUMENTS

## Examiner Document No. Name Date Class Subclass Filing Date Initial (If appropriate) AAAB FOREIGN PATENT DOCUMENTS Document No. Date Country Translation (Yes or No) ACAD AE OTHER DOCUMENTS Patent Abstracts of Japan No. 08-186249 (Abstract) AF Patent Abstracts of Japan No. 05-121450 (Abstract) AG AH Patent Abstracts of Japan No. 2000-012791 (Abstract) Patent Abstracts of Japan No. 2000-022158 (Abstract) ΑI Patent Abstracts of Japan No. 2000-286418 (Abstract) AJ

Date Considered

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